



PATENT APPLICATION
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q88071

Masakazu BABA, et al.

Appln. No.: 10/536,767

Group Art Unit: 3749

Confirmation No.: 4363

Examiner: Not Yet Assigned

Filed: May 27, 2005

For: **SAMPLE DRYING DEVICE AS WELL AS MASS SPECTROMETER AND MASS SPECTROMETRY SYSTEM THEREWITH**

LETTER CONCERNING PTO/SB/08 A & B

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Applicants respectfully submit this letter to correct a typographical error on the PTO/SB/08 A & B submitted on May 27, 2005. Applicant inadvertently mistyped Japanese Patent Publication No. 11-14614. Attached is a corrected PTO/SB/08 A & B for the Examiner to initial upon consideration of all of the references submitted on May 27, 2005.

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WASHINGTON OFFICE

23373

CUSTOMER NUMBER

Date: October 31, 2005

Respectfully submitted,


Howard L. Bernstein
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Substitute for Form 1449 A & B/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(use as many sheets as necessary)

Sheet

1

of

1

Complete if Known

Application Number	10/536,767
Confirmation Number	4363
Filing Date	May 27, 2005
First Named Inventor	Masakazu BABA
Art Unit	3749
Examiner Name	Not Yet Assigned
Attorney Docket Number	Q88071

U.S. PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Document Number		Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
		Number	Kind Code ² (if known)		
		US			
		US			
		US			
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		US			
		US			
		US			
		US			

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Cite No. ¹	Foreign Patent Document			Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Translation ⁶
		Country Code ³	Number ⁴	Kind Code ⁵ (if known)			
		JP	2001-264297	A	09-26-2001	Hitachi, Ltd.	
		JP	2002-236108	A	08-26-2002	Japan Science and Technology Corp.	
		WO	00/22426	A1	04-20-2000	Hitachi, Ltd.	
		JP	2000-162184	A	06-16-2000	Hitachi, Ltd.	
		JP	11-14614	A	01-22-1999	Hitachi, Ltd.	
		JP	10-48110	A	02-20-1998	Shimadzu Corporation	
		JP	6-10900	A	01-21-1994	Canon, Inc.	

NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No. ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city, and/or country where published.	Translation ⁶
		Sano et al. "Dai 63 Extended Abstracts; The Japan Society of Applied Physics, Vol. 3, 9-24-2002; pp 1146	
		Baba et al. "Sixth International Conference on Miniaturized Chemical and Biochemical Analysis Systems" (Micro Total Analysis Systems, 2002) 11-3-2002, Vol. 2, pp. 763-765	

Examiner Signature	Date Considered
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*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

¹Applicant's unique citation designation number (optional). ²See Kind Codes of USPTO Patent Documents at www.uspto.gov, MPEP 901.04 or follow the hyperlink from the title of the document to the intranet. ³Enter Office that issued the document, by the two-letter code (WIPO Standard ST. 3). ⁴For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. ⁵Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. ⁶Applicant is to indicate here if English language Translation is attached.